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10-6-06Sheet 1 of 1

Form PTO-1449 (REV. 8-93)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 100629.03	RULE 33(b) DIVISION OF APPLICATION NO. 10257,534		
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANT(S) Takuro OZAWA et al.				
		FILING DATE July 24, 2003	GROUP			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
J.L.		5,714,838	3-1998	HAIGHT et al.		
		6,072,450	6-2000	YAMADA et al.		
		5,587,329	12-96	HSEUH et al.		
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		6,243,069	06-01	OGAWA et al.		
J.V.		5,869,929	02-99	EIDA et al.		
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
J.L.		EP-A1-0 653 741	05-95	Europe		
		JP-A-8-129358	05-96	Japan		
		JP-B-227276	09-96	Japan		
		JP 08 241037 A	09-96	Japan		
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
J.L.		Alan G. Lewis, et al., Physical Mechanisms For Short Channel Effects In Polyimide Thin Film Transistors, IEEE, 1989, pgs. 134.1-134.4				
J.L.		Alan G. Lewis et al., Polyimide TFT Circuit Design and Performance, IEEE Journal of Solid-State Circuits, December 1992, Vol. 27, No. 12, pgs. 1833-1842.				
EXAMINER	<i>Jean degrenne</i>			DATE CONSIDERED 6-9-05		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

Date: July 24, 2003